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2813

PATENT  
Attorney Docket No.: 002818/PDD/PSI/JW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

AUG 13 2001  
TC 2800 MAIL ROOM

In re Application of: ) Group Art Unit: 2813  
Suketu A. Parikh ) Examiner: Pham, T  
Serial No.: 09/244,788 )  
 ) **TRANSMITTAL LETTER**  
Filed: 2/5/99 )  
 )  
For: Dual Damascene Misalignment )  
Tolerant Techniques For Vias And )  
Sacrificial Etch Segments )

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

TRANSMITTAL

Enclosed for the above-identified patent application please find:

- ☒ Clean Amended Claims in Response to Notice of Non-Compliance
- ☒ Information Disclosure Statement
- ☒ Form PTO-1449
- ☒ Certification under 37 CFR 1.97(e)
- ☒ Copy of 1 reference

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Respectfully submitted,  
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Dated: August 8, 2001

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